

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**INVENTORS: Richard Hsiao et al.**

**SERIAL NO.:**

**GROUP ART UNIT:**

**FILED:**

**EXAMINER:**

**FOR: Method Of Reducing ESD Damage In Thin Film Read  
Heads Which Enables Measurement Of Gap Resistance**

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Dear Sir:

Please amend the application as follows:

**In the Title:**

Please permit the title to be changed from "DEVICE AND METHOD OF REDUCING ESD DAMAGE IN THIN FILM READ HEADS WHICH ENABLES MEASUREMENT OF GAP RESISTANCES AND METHOD OF MAKING" to -- METHOD OF REDUCING ESD DAMAGE IN THIN FILM READ HEADS WHICH ENABLES MEASUREMENT OF GAP RESISTANCE--.

**In the Specifications:**

Page 1 lines 1-5, delete the title "DEVICE AND METHOD OF REDUCING ESD DAMAGE IN THIN FILM READ HEADS WHICH ENABLES

MEASUREMENT OF GAP RESISTANCES AND METHOD FO MAKING” and  
insert new title --METHOD OF REDUCING ESD DAMAGE IN THIN FILM READ  
HEADS WHICH ENABLES MEASUREMENT OF GAP RESISTANCE--.

Page 1, between lines 3 and 4, insert:

REFERENCE TO RELATED APPLICATION

*This is a divisional application of application Serial No. 09/753,804 filed 1/2/2001.*

On page 21, lines 1-4 please delete the title “DEVICE AND METHOD OF  
REDUCING ESD DAMAGE IN THIN FILM READ HEADS WHICH ENABLES  
MEASUREMENT OF GAP RESISTANCES AND METHOD OF MAKING” and  
insert new title, -- METHOD OF REDUCING ESD DAMAGE IN THIN FILM READ  
HEADS WHICH ENABLES MEASUREMENT OF GAP RESISTANCE--.

On page 21 lines 5-26 please delete the Abstract of the Disclosure, and  
insert the following new Abstract of the Disclosure:

--The present invention provides a method of manufacturing a  
magnetoresistive read head which reduces electrostatic discharge and allows  
measurement of gap resistances in the head--.